

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Meng Tao, et al.
Application No.: 10/822,343
Filing Date: April 12, 2004
Art Unit: 1775
Examiner: Timothy M. Speer
For: SUPPRESSION OF CHEMICAL REACTIVITY ON
SEMICONDUCTOR SURFACES

VIA EFS
Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

Dear Sir:

Applicants submit this Amendment filed after entry of a Request for Continued Examination under 37 C.F.R. § 1.114 and respectfully request entry of this Amendment and consideration of the remarks and evidence provided with this paper.

This Amendment is filed in reply to an Office Action mailed on November 28, 2007, that established a three-month shortened statutory period to respond. Applicants submit that this paper is timely filed with a Petition for Extension of Time for two months and the appropriate fees.

Applicants respectfully request reconsideration in view of the following:

Amendments to the Claims provided as a Listing of Claims that begin on page 2; and

Remarks that begin on page 4 of this paper; and

Appendix at the end of this paper that includes factual evidence in the form of a 2-page executed declaration submitted under 37 C.F.R. § 1.132.